

PATENT APPLICATION
Docket No.: 4591-366
Client Ref. No.: IC12242-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jeong-Min CHOI et al.

Serial No.:	10/750,983	Examiner:	Pert, Evan T.
Filed:	January 2, 2004	Group Art Unit:	2826
Confirmation No.:	5470		
For:	SEMICONDUCTOR DEVICE HAVING SILICIDE LAYERS AND METHOD OF FABRICATING THE SAME		

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, Paper No. 20070906, dated September 12, 2007, please amend the application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 3 of this paper and include both attached replacement sheets and annotated sheets showing changes.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks begin on page 9 of this paper.

An **Appendix** including amended drawing figures is attached following page 13 of this paper.